0/522086_ MPTO 16 MAR 2006 Application Not Yet Known APPLICANT'S ART CITATION Applicant Hoi-Sing KWOK et al. (Use several sheets if necessary) Group Art Unit __ Filing Date Herewith U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03) Date MM-YYYY Filing Date If Appropriate Examiner Initial Subclass Document Number Name Class 349 134 12-1996 Nakamura et al. US-5,583,680 US-US-US-US-US-US-US-US-FOREIGN PATENT DOCUMENTS Date MM-YYYY Translation Sub-Country Class Document Number class Yes No 07-2003 EP 1 042 702 B1 Europe GB 2 330 214 A 04-1999 United Kingdom OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) International Search Report for PCT/CN2004/001179.

Examiner

Date Considered

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.